

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Katsuhiko Miya

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For: SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING  
METHOD DRYING SUBSTRATE

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of a search report issued by a patent searching authority other than the PTO and the cited art together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Submission.

THIS CORRESPONDENCE IS BEING  
SUBMITTED ELECTRONICALLY  
THROUGH THE PATENT AND  
TRADEMARK OFFICE EFS FILING  
SYSTEM ON AUGUST 20, 2008.

Respectfully submitted,



MM:mjw

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